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PATENT

DOCKET NO.: 29284/592

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventors : Hideki SAGA  
Serial No. : 10/622,450  
Filed : 21 July 2003  
For : INFORMATION RECORDING APPARATUS  
Group Art Unit: 2655 Conf. No. 5239  
Examiner :

COMMISSIONER FOR PATENTS  
P. O. Box 1450  
Alexandria, Virginia 22313-1450

**INFORMATION DISCLOSURE STATEMENT  
UNDER 37 C.F.R. § 1.97 & § 1.98**

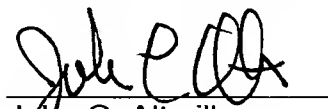
S I R:

In conformance with Applicant's duty of disclosure under 37 C.F.R. § 1.56 and § 1.97(b)(3), the references listed on the attached form PTO-1449 are hereby brought to the Examiner's attention.

The references were cited in an Office Action issued by the Chinese Patent Office on 6 August 2004. A copy of the Office Action is enclosed. An English Abstract is attached to the Chinese language publication.

It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear in the "references cited" on any patent to issue therefrom.

Respectfully submitted,

  
John C. Altmiller  
(Reg. No. 25,951)

Date: 4 October 2004

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**FORM PTO-1449**  
**INFORMATION DISCLOSURE**  
**STATEMENT BY APPLICANT(S)**

Atty Docket No.: 29284/592  
 Serial No. : 10/622,450  
 Applicants : Hideki SAGA  
 Filed : 21 July 2003  
 Group Art Unit : 2655  
 Examiner : CHU



**U.S. PATENT DOCUMENTS**

Examiner Initial	Patent Number	Patent Date	Name	Class/ Subclass	Filing Date
/KC/	6,125,084	09/26/00	SUKEDA et al.	369/13	

**FOREIGN PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Country	Class/ Subclass	Translation Yes No
/KC/	1197530A	10/29/98	China		ABS.

**OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner  
Initial

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**EXAMINER**

/Kim Kwok Chu/ (12/09/2008)

**DATE CONSIDERED**

12/09/2008

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.